



μ-PIC and its applications A. Takada (Kyoto University)

- > Our motivation
- $\succ \mu$ -PIC and MeV gamma-ray telescope
- $\succ \mu$ -PIC applications
- > New type μ -PIC





Gaseous Electron Tracker Micro Pixel Chamber (µ-PIC)



- 2D gaseous imaging detector
- by Print Circuit Board technology
- Each pixel works as like a proportional counter
- Large detection area : 10×10 cm² and 30×30 cm²
- High gas gain : max ~15000
- Fine position resolution : RMS ~120 μm
- Good gain uniformity
 - Stable operation over several months with the gain of ~6000









A. Takada+, ApJ, 733(2011), 13

1st balloon experiment (SMILE-I)

Sub-MeV gamma-ray imaging Loaded-on-balloon Experiment

Launched on Sep. 1, 2006 @ Sanriku (ISAS/JAXA)

- Test flight using (10 cm)³ ETCC
- Measure diffuse cosmic and atmospheric gamma ray
 - 0.1 1 MeV, @ 35 km, 3 hours



ETCC

Measured : 420 events

Simulation : ~400 events (cosmic + atmospheric)

Compton kinematic test and Particle identify provided low-background observation.











By imaging spectroscopy, ETCC can detect a very weak source without any shield !

Other μ -PIC applications



Development of new type $\mu\text{-PIC}$

Requirements from applications:

- 1. Higher gas gain
- 2. Suppression of discharge
- 3. Higher position resolution



- > Thick substrate
- Precise manufacturing
- ➤ Fine pitch



PCB technology :

- Thicker substrate causes thicker anode
- Precision of manufacturing is ~10 μm
- Minimum of anode diameter is 50 μm
 -> Pixel pitch is limited by anode

Micro Electro Mechanical Systems

- MEMS technology can make deep through-hole keeping anode diameter
- Precision of manufacturing is a few μm





- Large gain with stable operation : 22000 (no discharge during 20 hours) 15000 (no discharge over 300 hours)
- Good energy resolution :
 21.2% @ 5.89 keV (FWHM)
- > Discharge rate of MEMS μ -PIC is less than that of PCB μ -PIC.

Performance of test production improved those of current detectors. MEMS μ -PIC may become a next standard.

Summary

- Performance of PCB μ -PIC :
 - Large Detection area
 - High gas gain

 - Fine position resolution ~120 μ m (RMS)
 - Good gain uniformity < 5-7% (RMS, 100 cm²)
- Applications of µ-PIC :
 - Electron-Tracking Compton Camera
 - MeV gamma-ray astronomy, Medical imaging, Environmental monitoring
 - Neutron Imaging
 - Dark matter search
- Development of MEMS μ-PIC :
 - High gas gain
 - Stable operation
- ~22000 during 20 hours
 - ~15000 over 300 hours

Discharge rate is less than that of PCB type

- Good energy resolution 21.2% @ 5.89 keV (FWHM)

$10 \times 10, 30 \times 30 \text{ cm}^2$

- ~6000 (stable operation), 15000 (max)
- Energy resolution ~30% @ 5.89 keV (FWHM)